

Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/607,800
				Filing Date	June 27, 2003
				First Named Inventor	Kramadhathi V. Ravi
				Art Unit	2818
				Examiner Name	David C. Nelms
Sheet	2	of	2	Attorney Docket Number	42P16832

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
P D	5	KLEIN C.A. et al., "Chemically vapor-deposited diamond: strains, stresses, and fracture strength", Proceedings of the Fourth International Symposium on Diamond Materials Electrochem, 1995, pp. 661-674, XP009042938, SOC Pennington, NJ, USA.	
P D	6	Invitation To Pay Additional Fees, International App. No.: PCT/US2004/018338, Applicant Ref. No.: P16832PCT, Date Mailed: 7 Feb. 2005, pages: 5.	

Examiner Signature	PHUC T. DANG	Date Considered	3/29/05
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number.²Applicant is to place a check mark here if English language Translation is attached.

Based on PTO/SB/08B (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wlr) 08/11/2003.
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